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March 24, 2003

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Paul E. Rauch, Ph.D.

Name of Applicant, Assignee or
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GROUP 1700

Our File No. 09799940-0120

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Thinghao F. Wang

Serial No. 10/071,809

Filing Date: February 7, 2002

For METHOD FOR SELECTIVELY
ETCHING SILICON AND/OR METAL
SILICIDE

Examiner: Deo, Duy Vu

Group Art Unit No.: 1765

TRANSMITTAL

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Transmitted herewith is:

- ☒ Credit Card Payment Form
- ☒ Three Month Extension of Time (in duplicate)
- ☒ Amendment
- ☒ Information Disclosure Statement
- ☒ PTO-1449
- ☒ References C1-C22
- ☒ No additional fee is required for additional Independent, Dependent or Multiple Dependent Claims.

					Small Entity		or	Other Than A Small Entity	
	Claims Remaining After Amendment		Highest No. Previously	Present Extra	Rate	Addit. Fee		Rate	Addit. Fee
Total	18	Minus	21	0	x 9 =	\$		x 18 =	\$ 0
Indep.	3	Minus	3	0	x 42 =	\$		x 84 =	\$ 0
<input type="checkbox"/> First Presentation of Multiple Dependent Claim					x 140 =	\$		x 280 =	\$ 0
Total Additional Fee						\$		Total	\$ 0

- ☒ The Commissioner is hereby authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 19-3140. A duplicate copy of this sheet is attached.

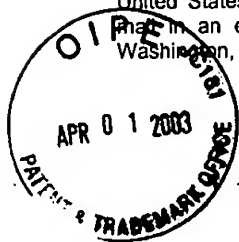
Respectfully submitted,

Paul E. Rauch, Ph.D.,
Registration No. 38,591
Attorney for Applicant

SONNENSCHN NATH & ROSENTHAL
P. O. BOX 061080
WACKER DRIVE STATION, SEARS TOWER
CHICAGO, IL 60606
(312) 876-8000

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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sirs:

In response to the Official Action of September 24, 2002 Applicant respectfully requests reconsideration in light of the following amendments and remarks.